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APPLICATION NO.	D. FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
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HARNESS	, DICKE	Y & PIERCE, P.L.	LEBRON, JANNELLE M			
P.O. BOX 8		.S, MI 48303	ART UNIT	PAPER NUMBER		
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				DATE MAILED: 02/10/2006		

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)	
•		10/789,940	SHINKAWA ET AI	L.
. Office Action Su	mmary	Examiner	Art Unit	
		Jannelle M. Lebron	2861	
The MAILING DATE of to Period for Reply	his communication app	ears on the cover sheet wit	th the correspondence ad	Idress
A SHORTENED STATUTORY WHICHEVER IS LONGER, FF - Extensions of time may be available und after SIX (6) MONTHS from the malling - If NO period for reply is specified above, - Failure to reply within the set or extende Any reply received by the Office later tha earned patent term adjustment. See 37	COM THE MAILING DA er the provisions of 37 CFR 1.13 late of this communication. the maximum statutory period w d period for reply will, by statute, in three months after the mailing	ATE OF THIS COMMUNIC 16(a). In no event, however, may a re- rill apply and will expire SIX (6) MON- cause the application to become AB.	CATION.  apply be timely filed  THS from the mailing date of this control (35 U.S.C. § 133).	
Status				
•	2b)⊠ This in condition for allowar	ebruary 2004. action is non-final. ace except for formal matte fx parte Quayle, 1935 C.D		e merits is
Disposition of Claims				
4)	is/are withdray owed.  and 18-20 is/are reject is/are objected to. ect to restriction and/or eted to by the Examine	ed.  election requirement.		
	that any objection to the	drawing(s) be held in abeyan ion is required if the drawing(	ce. See 37 CFR 1.85(a). (s) is objected to. See 37 Cl	FR 1.121(d).
Priority under 35 U.S.C. § 119				
<ul><li>2. Certified copies of</li><li>3. Copies of the cert</li></ul>	None of: the priority documents the priority documents fied copies of the prior the International Bureau	s have been received. s have been received in A ity documents have been ı (PCT Rule 17.2(a)).	pplication No received in this National	Stage
Attachment(s)  1) Notice of References Cited (PTO-89)  2) Notice of Draftsperson's Patent Draftsperson's Paten	wing Review (PTO-948) (PTO-1449 or PTO/SB/08)	Paper No(s 5) Notice of Ir	Summary (PTO-413) s)/Mail Date nformal Patent Application (PTO 	O-152)

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#### **DETAILED ACTION**

## Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 2. Claims 1-4, 8-11, 13-14, and 18-20 are rejected under 35 U.S.C. 102(b) as being anticipated by Kanayama (US Patent 4,498,088).

#### Claim 1:

Kanayama discloses "a droplet ejecting apparatus comprising: a droplet ejecting head including:

a vibration plate (20 in figure 1);

an actuator (22 in figure 1 and 2) for displacing the vibration plate;

a cavity (12 ion figure 1) filled with a liquid and having an interior pressure to be increased and decreased by a displacement of the vibration plate (column 2, lines37-46); and

a nozzle (14 in figure 1) communicating with the cavity and for ejecting the liquid as a droplet depending upon an increase and decrease of the pressure within the cavity (column 2, lines 32-36);

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a drive circuit for driving the actuator (26 in figure 2); and an ejection abnormality detecting device (28 in figure 2) having a detecting device (22 in figure 2; column 1, lines 59-63) for detecting residual vibration of the vibration plate displaced by the actuator after the actuator is driven by the drive circuit, to detect an abnormality of droplet ejection depending upon a vibration pattern of the residual vibration of the vibration plate detected by the residual vibration detecting device (column 2, 58-63; column 3, lines 9-14)."

#### Claim 2:

Kanayama discloses a droplet ejecting apparatus "wherein the ejection abnormality detecting device (28 in figure 2) includes a determining device (22 in figure 2) for determining a presence or absence of a droplet ejection abnormality of the droplet ejection head depending upon the vibration pattern of residual vibration of the vibration plate (column 2, lines 58-63; column 3, lines 9-14)."

## • Claim 3:

Kanayama discloses a droplet ejecting apparatus "wherein the determining device determines a cause of the ejection abnormality, when the presence of a droplet ejection abnormality is determined (column 3, lines 22-24)."

#### Claim 4:

Kanayama discloses a droplet ejecting apparatus "wherein the vibration pattern of the residual vibration of the vibration plate includes a period of the residual vibration (column 3, lines 15-22; as seen in figure 3(A))."

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## Claim 8:

Kanayama discloses a droplet ejecting apparatus "further comprising a storage device for storing a result of the determination made by the determining device (column 4, lines 48-51)."

## Claim 9:

Kanayama discloses a droplet ejecting apparatus "further comprising a switch device (30 in figure 2) for switching, after a droplet ejecting operation by the actuator, the actuator from the drive circuit to the ejection abnormality detecting device (column 2, lines 66-68; column 3, lines 42-54)."

#### Claim 10:

Kanayama discloses a droplet ejecting apparatus "wherein the residual vibration detecting device has an oscillation circuit, the oscillation circuit oscillating based on a capacitance component of the actuator varying depending upon the residual vibration of the vibration plate (column 3, lines 47-52)."

#### Claim 11:

Kanayama discloses a droplet ejecting apparatus "wherein the oscillation circuit comprises a CR oscillation circuit having a capacitance component of the actuator and a resistance component of a resistance element connected to the actuator (as seen in figure 9)."

## • Claim 13:

Kanayama discloses a droplet ejecting apparatus "wherein the residual vibration detecting device includes an F/V conversion circuit for generating a voltage waveform of

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the residual vibration of the vibration plate from a predetermined signal group generated based on an oscillation frequency change in an output signal of the oscillation circuit (column 3, line 56 – column 4, line 19)."

## • Claim 14:

Kanayama discloses a droplet ejecting apparatus "wherein the residual vibration detecting device includes a waveform shaping circuit for shaping a voltage waveform of the residual vibration of the vibration plate generated by the F/V conversion circuit into a predetermined waveform (column 3, line 56 – column 4, line 19)."

#### • Claim 18:

Kanayama discloses a droplet ejecting apparatus "wherein the actuator comprises an electrostatic actuator (as seen in figure 2, the actuator is made as a parallel plate capacitor)."

#### • Claim 19:

Kanayama discloses a droplet ejecting apparatus "wherein the actuator comprises a piezoelectric actuator utilizing a piezoelectric effect of a piezoelectric element (column 2, lines 37-46)."

#### • Claim 20:

Kanayama discloses "a droplet ejecting head ejection abnormality detecting/determining method comprising the steps of:

detecting residual vibration of a vibration plate (20 in figure 1) after carrying out an operation for ejecting a liquid within a cavity (12 in figure 1) as a droplet from a nozzle (14 in figure 1) by driving an actuator to vibrate the vibration plate;

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detecting a droplet ejection abnormality (column 2, lines 58-63; column 3, lines 9-14); and

determining a cause of the droplet ejection abnormality depending upon a detected vibration pattern of the residual vibration of the vibration plate (column 3, lines 22-24)."

# Allowable Subject Matter

- 3. Claims 5-7, 12, and 15-17 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
- 4. The following is a statement of reasons for the indication of allowable subject matter:

Prior art does not disclose or suggest either alone or combined the claimed "(...)"

#### Claim 5:

Prior art does not disclose or suggest either alone or combined the claimed "wherein, when the period of the residual vibration of the vibration plate is shorter than a predetermined first period, the determining device determines that the cause of the droplet ejection abnormality is that there is an air bubble mixed in the cavity."

#### Claim 12:

Prior art does not disclose or suggest either alone or combined the claimed "wherein the oscillation circuit has an oscillation frequency configured one figure higher than a vibration frequency of the residual vibration of the vibration plate."

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#### • Claim 15:

Prior art does not disclose or suggest either alone or combined the claimed "wherein the waveform shaping circuit includes a DC component removing device for removing a direct-current component from a voltage waveform of the residual vibration of the vibration plate generated by the F/V conversion circuit, and a comparator for comparing between a voltage waveform removed from the direct-current component by the DC component removing device and a predetermined voltage value, the comparator generating and outputting a rectangular wave depending upon the voltage comparison."

5. Claims 6, 7, 16, and 17 are considered allowable subject matter since they depend on allowable claims.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jannelle M. Lebron whose telephone number is (571) 272-2729. The examiner can normally be reached on Monday thru Friday 8:30am-5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Stephen D. Meier can be reached on (571) 272-2149. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

JML 02/03/2006

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